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## \*BIBDATASHEET\*

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**CONFIRMATION NO. 2544** 

DID Data Sheet					,			~~~~~	
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APPLICANTS									
Matsumoto Toshiyuki, Sanda-shi, JAPAN;									
Yakabe Masami, Amagasaki-shl, JAPAN; Hirota Yoshihiro, Kyoto-shi, JAPAN;									
CONTINUING DATA									
FOREIGN APPLICATIONS									
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/09/2001									
Foreign Priority claime 35 USC 119 (a-d) con		yes Ono Met after	Allowance	STATE OR	SH	IEETS	то	TAL	INDEPENDENT
Verified and Acknowledged	Exe	whiner's Signature I	 nitials	COUNTRY JAPAN	DR	AWING 13		IMS も名1	CLAIMS
ADDRESS 23646 BARNES & THORNBURG 750-17TH STREET NW SUITE 900 WASHINGTON, DC 20006									
TITLE Capacitance measurement method of micro structures of integrated circuits									
NAME OF THE OWNER OF THE PARTY						☐ All Fees			
FILING FEE	FEES: Authority has been given in Paper					☐ 1.16 Fees ( Filing ) ☐ 1.17 Fees ( Processing Ext. of time )			
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